



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re application of

Kazumasa KAMACHI et al.

Serial No. 10/551,818

Filed June 22, 2006

:

: **Confirmation No. 3974**

: **Mail Stop: PCT**

: **Attorney Docket No. 2005_1535A**

METHOD AND APPARATUS FOR THE
METHANE FERMENTATION TREATMENT OF
WASTEWATER CONTAINING SULFUR COMPOUND

REQUEST FOR CORRECTED FILING RECEIPT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

A corrected filing receipt is requested in the above-referenced case. A copy of the original filing receipt is enclosed, with the changes noted thereon.

Expedited issuance of the corrected filing receipt is respectfully requested.

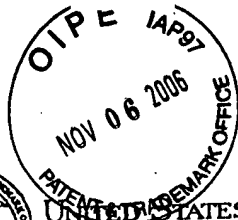
Respectfully submitted,

Kazumasa KAMACHI et al.

By

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November 6, 2006



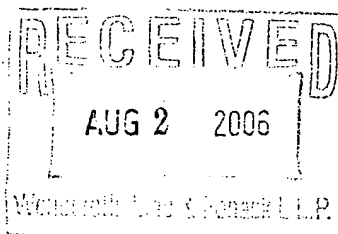
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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/551,818	06/22/2006	1724	1030	2005_1535A	10	7	2

CONFIRMATION NO. 3974

513
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2033 K STREET N. W.
SUITE 800
WASHINGTON, DC 20006-1021



FILING RECEIPT



OC000000019757249

Date Mailed: 08/01/2006

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Applicant(s)

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Power of Attorney: The patent practitioners associated with Customer Number 513.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP04/04403 03/29/2004

Foreign Applications

JAPAN 2003-094373 03/31/2003

If Required, Foreign Filing License Granted: 07/25/2006

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US10/551,818**

Projected Publication Date: 11/02/2006

Non-Publication Request: No

Early Publication Request: No

Title

apparatus
 Method and ~~system~~ for the methane fermentation treatment of wastewater containing sulfur compound

Preliminary Class

210

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